



SFW  
PATENT  
0020-5179P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Zhiqiang WEI et al. Conf.: 6865

Appl. No.: 10/665,496 Group: 1775

Filed: September 22, 2003 Examiner: S. STEIN

For: A THIN FILM OF METAL OXIDE AND A METHOD  
FOR PREPARING IT

LARGE ENTITY TRANSMITTAL FORM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 28, 2005

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.

- The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- Petition for \_\_\_\_\_ month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- No fee is required.
- A check in the amount of \$0.00 is enclosed.
- Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

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ADM:gmh  
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Attachment(s)



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REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 28, 2005

Sir:

In reply to the Restriction Requirement dated February 28, 2005, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.